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MAIL STOP
AMENDMENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Y. Granik et al.

Attorney Docket No.: MEGC117332

Application No.: 09/898,431

Group Art Unit: 2123

Filed: July 2, 2001

Examiner: M.C. Hogan

Title: METHOD OF COMPENSATING FOR ETCH EFFECTS IN
PHOTOLITHOGRAPHIC PROCESSING

AMENDMENT

Seattle, Washington 98101

May 19, 2005

TO THE COMMISSIONER FOR PATENTS:

INTRODUCTORY COMMENTS

Please amend the above-identified application as follows.

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